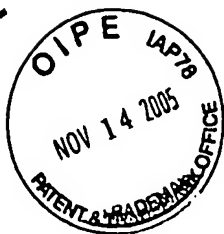


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November 9, 2005

Date of Signature

Re: Application of: Ausserlechner  
Serial No.: 10/733,961  
Filed: December 11, 2003  
For: Semiconductor Structure with Integrated Shield  
Group Art Unit: 2815  
Examiner: Edward Joseph Wojciechowicz  
Docket No.: 1890-0019

AMENDMENT AFTER FINAL

Sir:

In response to the Office Action dated July 9, 2005 for the above-identified patent  
application, please amend the application as follows:

Amendments to the Claims begin at page 2 of this document.